"Method for Forming Capacitor of Semiconductor

Device"

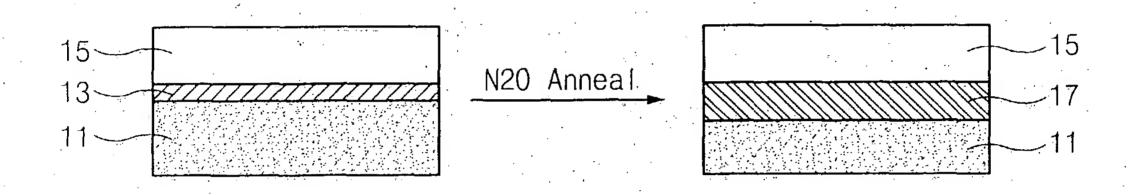


Fig.1 <Prior Art>

"Method for Forming Capacitor of Semiconductor Device"

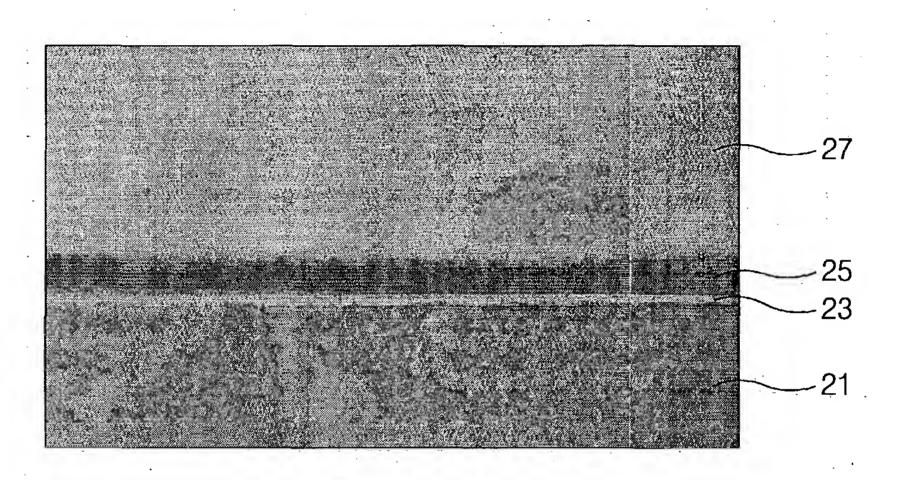


Fig.2 < Prior Art >

"Method for Forming Capacitor of Semiconductor Device"

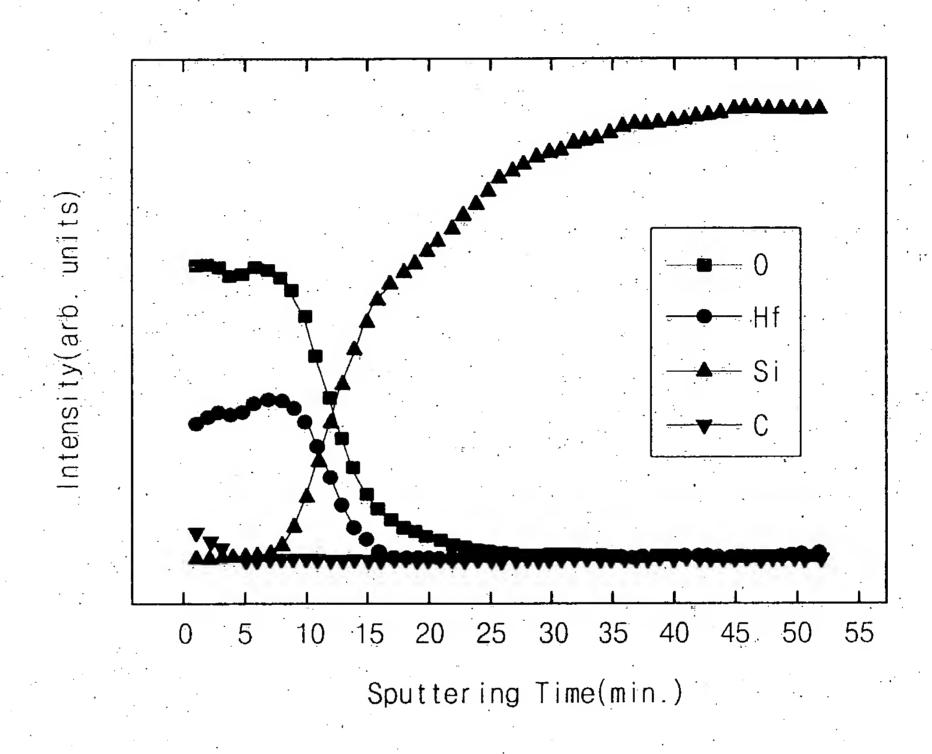


Fig.3a <Prior Art>

"Method for Forming Capacitor of Semiconductor

Device"

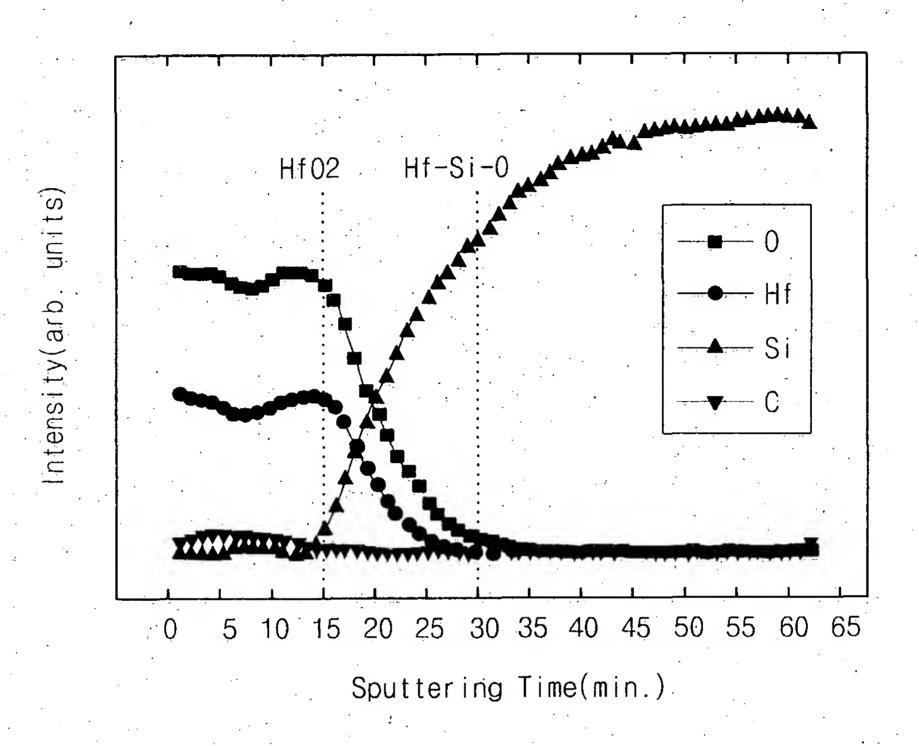


Fig.3b <Prior Art>

"Method for Forming Capacitor of Semiconductor Device"

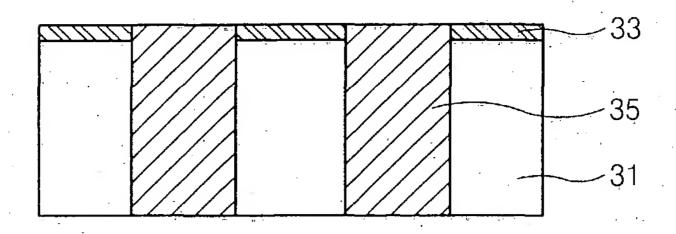


Fig.4a

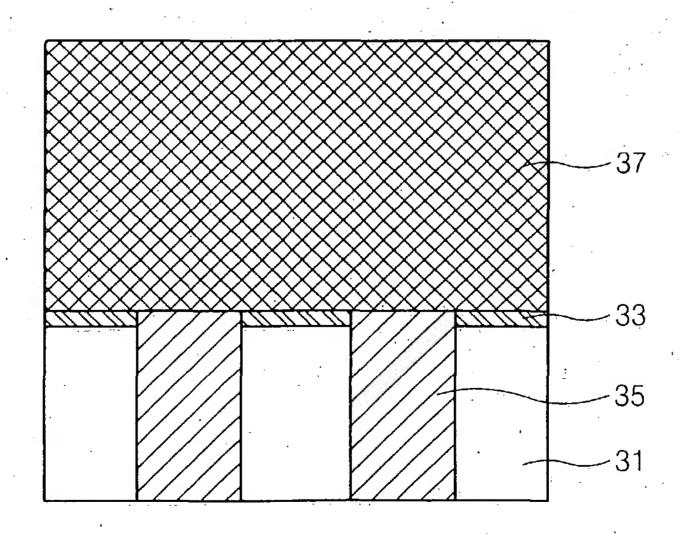


Fig.4b

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Device"

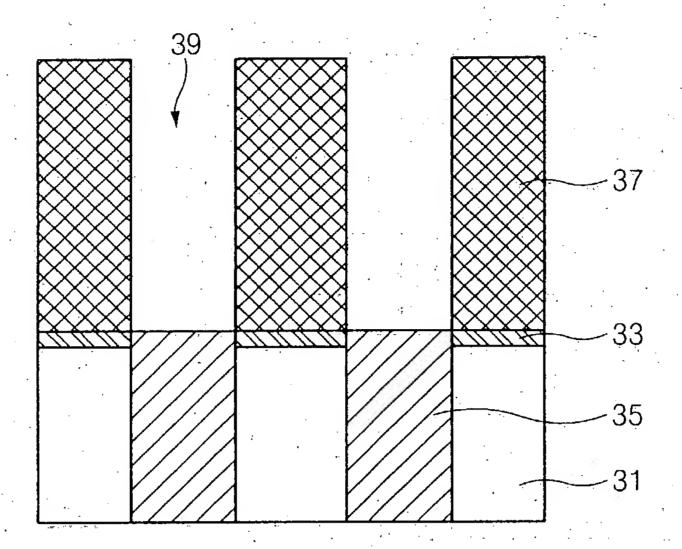


Fig.4c

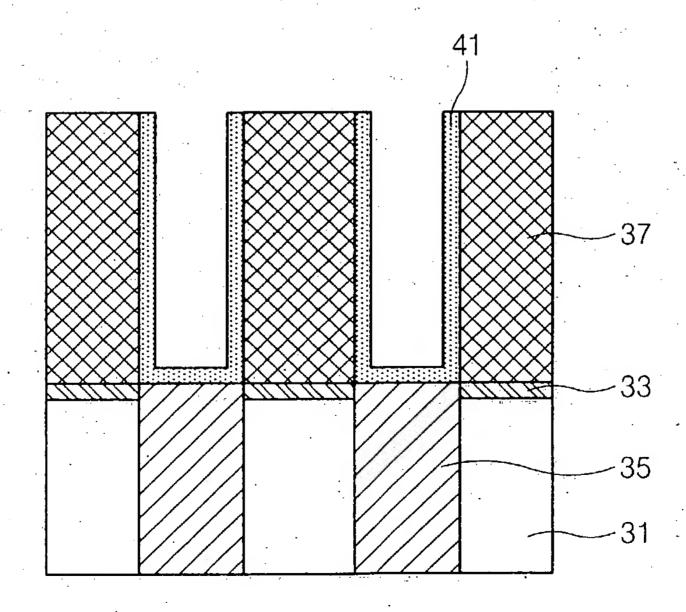


Fig.4d

"Method for Forming Capacitor of Semiconductor

Device"

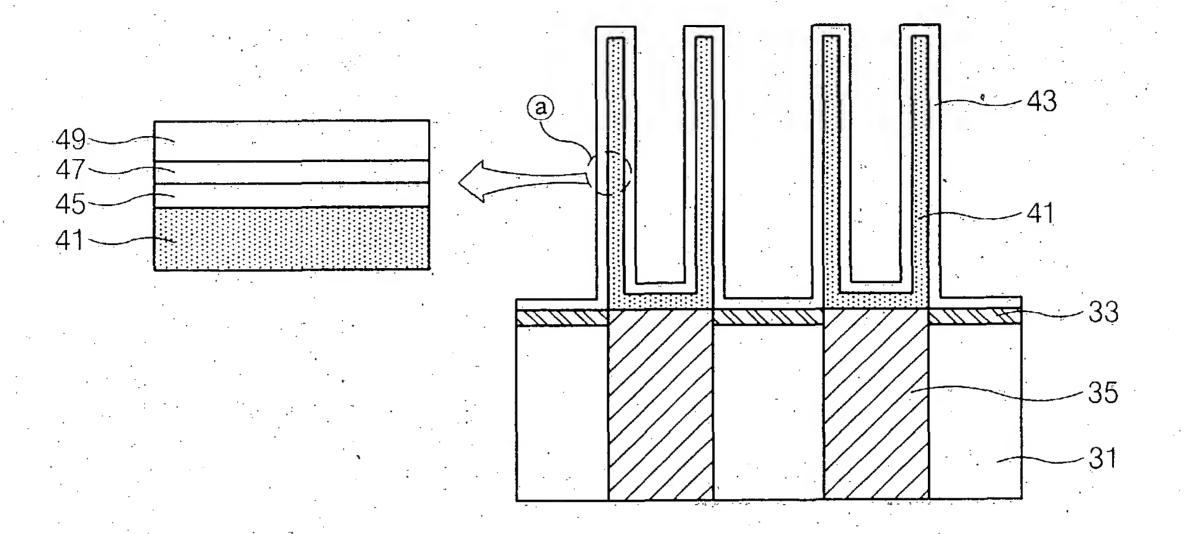


Fig.4e

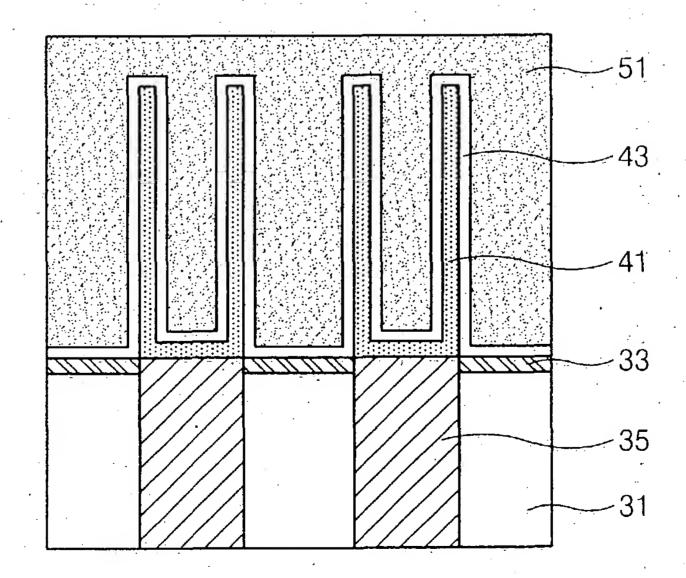


Fig.4f

"Method for Forming Capacitor of Semiconductor

Device"

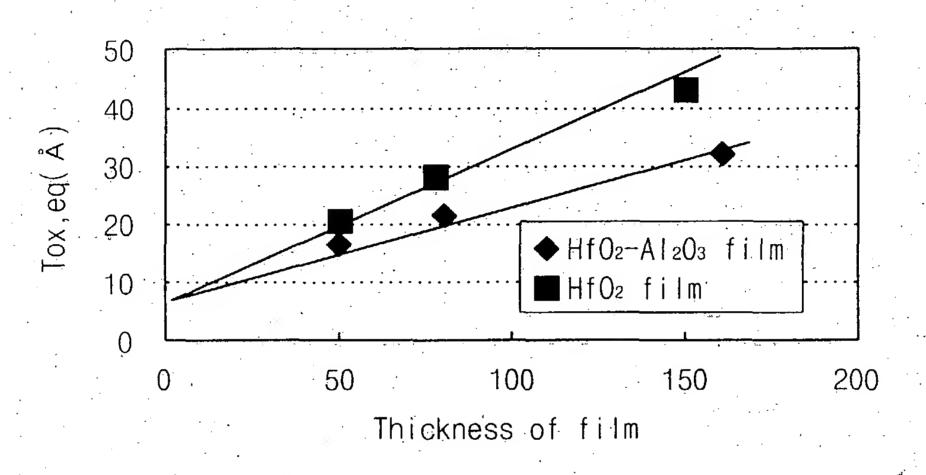


Fig.5